
OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	PRODUCTION METHOD OF SIC MONITOR WAFER
Attorney Docket Number::	120524
Total Drawing Sheets::	5
Small Entity::	No

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Isao
Family Name::	YAMADA
City of Residence::	Himeji-shi
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Jiro
Family Name::	MATSUO
City of Residence::	Kyoto-shi
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Noriaki
Family Name::	TOYODA
City of Residence::	Himeji-shi
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Kazutoshi
Family Name::	MURATA
City of Residence::	Tamano-shi
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Naomasa
Family Name::	MIYATAKE
City of Residence::	Tamano-shi
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number:: 25944

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP03/00175	01/10/2003
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-45725	02/22/2002	Yes
Assignee Information			
Assignee Name::		MITSUI ENGINEERING & SHIPBUILDING CO., LTD.	
Street of mailing address::		6-4, Tsukiji 5-chome,	
City of mailing address::		Chuo-ku,	
State or Province of mailing address::		Tokyo	
Country of mailing address::		Japan	
Postal or Zip Code of mailing address::		104-8439	